

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	(laser near annealing) and (beam near splitter) and photomask	USOCR	OR	ON	2005/09/01 13:47
L2	0	(laser near annealing) and (beam near splitter)	USOCR	OR	ON	2005/09/01 13:46
L3	0	(annealing near silicon) and laser and recrystalliz\$6	USOCR	OR	ON	2005/09/01 13:47
L4	43	(laser near annealing) and (beam near splitter) and photomask	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/01 13:47
L5	155	(annealing near silicon) and laser and recrystalliz\$6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/01 13:47
L6	43	(laser near annealing) and (beam near splitter) and photomask	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/01 13:55
L7	139	I5 and (amorphous)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/01 13:48
L8	127	I5 and (amorphous near silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/01 13:48
L9	110	I8 and (silicon near film)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/01 13:48
L10	7	I9 and ((laser or beam) near (split or splitter))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/01 13:49
L11	1	I6 and ((delay or timing) near (laser or beam))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/01 13:52

L12	1	I6 and ((optical near path) near (length or distance or measurement or measure))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/01 13:52
L13	4	I6 and recrystallization	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/01 13:56
L14	627	219/121.65	US-PGPUB; USPAT	OR	ON	2005/09/01 13:56
L15	41	I14 and (laser near annealing)	US-PGPUB; USPAT	OR	ON	2005/09/01 13:56
L16	12	I15 and (beam near splitter)	US-PGPUB; USPAT	OR	ON	2005/09/01 13:57